## 505709423 10/07/2019

# PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1 Stylesheet Version v1.2 EPAS ID: PAT5756233

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

#### **CONVEYING PARTY DATA**

Name	Execution Date
KAZUKI WATANABE	10/03/2019
HIRONORI WAKANA	01/16/2018
YOSHIHITO NARITA	10/24/2018
MINORU KANEKO	10/24/2018
ATSUSHI SUZUKI	10/03/2019
TADANORI KOIKE	10/03/2019
KEIICHI NAGASHIMA	10/04/2019

#### **RECEIVING PARTY DATA**

Name: HITACHI SYSTEMS, LTD.	
Street Address:	2-1, OSAKI 1-CHOME, SHINAGAWA-KU
City:	TOKYO
State/Country:	JAPAN
Postal Code:	141-8672

#### **PROPERTY NUMBERS Total: 1**

Property Type	Number	
Application Number:	15742888	

## CORRESPONDENCE DATA

Fax Number:

Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

Phone: 212-999-6180
Email: office@ip-law.co.il

Correspondent Name: SOROKER AGMON NORDMAN ADVOCATES AND PATE

Address Line 1: 8 HAHOSHLIM STREET

Address Line 2: P.O. BOX 12425

Address Line 4: HERZLIYA, ISRAEL 4672408

ATTORNEY DOCKET NUMBER: 7249/3

NAME OF SUBMITTER: DANIEL SCHATZ

SIGNATURE: /DANIEL SCHATZ/

DATE SIGNED: 10/07/2019

505709423 REEL: 050634 FRAME: 0700

# Total Attachments: 6 source=Assign1#page1.tif source=Assign1#page2.tif source=Assign1#page3.tif source=Assign1#page4.tif source=Assign1#page5.tif source=Assign1#page6.tif

## **ASSIGNMENT**

(譲渡証)

As a below named inventor, I hereby declare that:

IN CONSIDERATION of the sum of One Dollar (\$1.00) or the equivalent thereof, and other good and valuable consideration paid to me citizen of Japan by Hitachi Systems, Ltd., a corporation organized under the laws of Japan,

located at 2-1, Osaki 1-chome, Shinagawa-ku, Tokyo 141-8672, Japan,

receipt of which is hereby acknowledged I do hereby sell and assign to said Hitachi Systems, Ltd., its successors and assigns, all my right, title and interest, in and for the United States of America, in and to

# PHOTOVOLTAIC POWER GENERATION INSPECTION SYSTEM AND PHOTOVOLTAIC POWER GENERATION INSPECTION METHOD

invented by me (if only one is named below) or us (if plural inventors are named below) and described in the application for United States Letters Patent therefor, executed on even date herewith, and all United States Letters Patent which may be granted therefor, and all divisions, continuations and extensions thereof, the said interest being the entire ownership of the said Letters Patent when granted,

to be held and enjoyed by said Hitachi Systems, Ltd.,

its successors, assigns or other legal representatives, to the full end of term for which said Letters Patent may be granted as fully and entirely as the same would have been held and enjoyed by me or us if this assignment and sale had not been made;

And I hereby agree to sign and execute any further documents or instruments which may be necessary, lawful, and proper in the prosecution of the above-named application or in the preparation and prosecution of any continuing, continuation-in-part, substitute, divisional, renewal, reviewed or reissue applications or in any amendment, extension, or interference proceedings, or otherwise to secure the title thereto in said assignee;

And I do hereby authorize and request the Commissioner of Patents to issue said Letters Patent to said Hitachi Systems, Ltd.

Signed on the date(s) indicated aside our signatures:

	INVENTOR(S)	nate pigued	
(発明者プルネームサイン)		(署名目)	
1)	Ziveonori Wahana (Hironori WAKANA)	January 16, 2018	
2)	yoshihito Nunita <del>YoshiLo</del> Yoshihito Nanitavosana nama	October 24. 2018	
3) ्	(Atsushi SUZUKI)		
4)	(Tadanori KOIKE)		
5)	(Kelichi NAGASHIMA)	4	

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to be held and enjoyed by said. Hitachi Systems, Ltd.,

its successors, assigns or other legal representatives, to the full end of term for which said Letters Patent may be granted as fully and entirely as the same would have been held and enjoyed by me or us if this assignment and sale had not been made:

And I hereby agree to sign and execute any further documents or instruments which may be necessary, lawful, and proper in the prosecution of the above-named application or in the preparation and prosecution of any continuing, continuation-in-part, substitute, divisional, renewal, reviewed or reissue applications or in any amendment, extension, or interference proceedings, or otherwise to secure the title thereto in said assignee;

And I do hereby authorize and request the Commissioner of Patents to issue said Letters Patent to said Hitachi Systems, Ltd.

Signed on the date(s) indicated aside our signatures:

INVENTORIS

		すフルネームサイン)			(署名日)
1	) <u>Mimarin</u>	Kaneko	(Minoru KANEKO)	24 006.	2018
2	,				
3	,				

## **ASSIGNMENT**

(籬渡証)

As a below named inventor, I hereby declare that:

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to be held and enjoyed by said Hitachi Systems, Ltd.,

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And I hereby agree to sign and execute any further documents or instruments which may be necessary, lawful, and proper in the prosecution of the above-named application or in the preparation and prosecution of any continuing, continuation-in-part, substitute, divisional, renewal, reviewed or reissue applications or in any amendment, extension, or interference proceedings, or otherwise to secure the title thereto in said assignee;

And I do hereby authorize and request the Commissioner of Patents to issue said Letters Patent to said Hitachi Systems, Ltd.

Signed on the date(s) indicated aside our signatures:

INVENTOR(S) (発明者フルネームサイン)			Date Signed (署名日)	
.1)	<u>绮木 牧</u>	(Albushi SUZUKI)	Oct. 3, 2019	
2) _	小池忠典	(Tadanori KOIKE)	Oct. 3, 2019	
3) _	長島塔一	(Kelichi NAGASHIMA)	Oct. 4. 2019	
4) ~				
5) _				

Doc code: Oath

Document Description: Oath or declaration filed

PTO/AIA/02 (07-13)

Approved for use through 04/30/2017. CMB 0651-0032

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# SUBSTITUTE STATEMENT IN LIEU OF AN OATH OR DECLARATION FOR UTILITY OR DESIGN PATENT APPLICATION (35 U.S.C. 115(d) AND 37 CFR 1.64)

Title of Invention	PHOTOVOLTAIC POWER GENERATION INSPECTION SYSTEM AND PHOTOVOLTAIC POWER GENERATION INSPECTION METHOD			
This stateme	ent is directed to:			
The att	ached application,			
OR				
United :	States application or PCT intern	ational application numbe	oer <u>15/742,888</u> filed on <u>January 9, 2018</u>	
LEGAL NA	ME of inventor to whom th	nis substitute stateme	ent applies:	
, , , , , , , , , , , , , , , , , , ,	Name (first and middle (if any)) WATANABE	and Family Name or Sui	ımame)	
Residence (	except for a deceased or legally	r incapacitated inventor):	· · · · · · · · · · · · · · · · · · ·	
<sub>civ</sub> Tok	yo	Cento	<sub>Country</sub> Japan	
	ess (except for a deceased or legatly thi, Ltd., 6-6, Marunouch		da-ku <sub>Zip</sub> 100-8280 <sub>Country</sub> <b>Japan</b>	
I believe the above-named inventor or joint inventor to be the original inventor or an original joint inventor of a claimed invention in the application.  The above-identified application was made or authorized to be made by me.  I hereby acknowledge that any willful false statement made in this statement is punishable under 18 U.S.C. 1001 by fine or imprisonment of not more than five (5) years, or both.				
L ■ A □ P	egal Representative (for deceas ssignee, erson to whom the inventor is u erson who otherwise shows a s oint Inventor.	sed or legally incapacitate	ted inventor only),	

[Page 1 of 2]

This collection of information is required by 35 U.S.C. 115 and 37 CFR 1.63. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.11 and 1.14. This collection is estimated to take 1 minute to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450, DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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# SUBSTITUTE STATEMENT

Circumstances permitting execution of this	substitute statement:				
Inventor is deceased,					
Inventor is under legal incapacity,					
Inventor cannot be found or reach	ed after diligent effort, o	ır			
Inventor has refused to execute th	e oath or declaration ur	nder 37 CFR 1.63.			
If there are joint inventors, please check the	e appropriate box belov	r.			
An application data sheet under 3 or is currently submitted.	7 CFR 1.76 (PTO/AIA/1	4 or equivalent) naming the entir	e inventive entity has been		
OR					
An application data sheet under 3 Statement Supplemental Sheet (P information is attached. See 37 Cl	TO/AIA/11 or equivaler	4 or equivalent) has not been su it) naming the entire inventive en	omitted. Thus, a Substitute tity and providing inventor		
	WARNING	<b>}</b> :			
contribute to identity theft. Personal informat (other than a check or credit card authorization support a petition or an application. If this petitioners/applicants should consider redact USPTO. Petitioner/applicant is advised that is application (unless a non-publication request patent. Furthermore, the record from an abainsferenced in a published application or an is PTO-2038 submitted for payment purposes a	on form PTO-2038 subritype of personal informing such personal informine record of a patent a in compliance with 37 indoned application may sued patent (see 37 CF)	nitted for payment purposes) is nation is included in documents so nation from the documents before poscation is available to the public GFR 1.213(a) is made in the applicy also be available to the public if FR 1.14). Checks and credit card	ever required by the USPTO ibmitted to the USPTO, a submitting them to the cafter publication of the ication) or issuance of a the application is authorization forms		
PERSON EXECUTING THIS SUBSTITUTE :	STATEMENT:				
<sub>Name:</sub> Shigeaki Akamats	Name: Shigeaki Akamatsu Oct. 3 , 20/9				
Signature: 木松 重	9/4				
APPLICANT NAME AND TITLE OF PERSO					
If the applicant is a juristic entity, list the applicant name and the title of the signer:  Hitachi Systems, Ltd.  Applicant Name:					
Title of Person Executing This Substitute Statement Department Ma	inager, Intellectual P	roperty Department, Researc	h & Development Division		
The signer, whose title is supplied above, is authorized to act on behalf of the applicant. Residence of the signer (unless provided in an application data sheet, PTO/AIA/14 or equivalent):					
Tokyo State Country Japan					
Mailing Address of the signer (unless provided in an application data sheet, PTO/AIA/14 or equivalent)					
2-1, Osaki 1-chome, Shinagawa-ku					
<sub>city</sub> Tokyo	State	741-8672	Lountry Japan		
Note: Use an additional PTO/AIA/02 form for after diligent effort, or has refused to execute			annot be found or reached		

[Page 2 of 2]

## **Privacy Act Statement**

The **Privacy Act of 1974 (P.L. 93-579)** requires that you be given certain information in connection with your submission of the attached form related to a patent application or patent. Accordingly, pursuant to the requirements of the Act, please be advised that: (1) the general authority for the collection of this information is 35 U.S.C. 2(b)(2); (2) furnishing of the information solicited is voluntary; and (3) the principal purpose for which the information is used by the U.S. Patent and Trademark Office is to process and/or examine your submission related to a patent application or patent. If you do not furnish the requested information, the U.S. Patent and Trademark Office may not be able to process and/or examine your submission, which may result in termination of proceedings or abandonment of the application or expiration of the patent.

The information provided by you in this form will be subject to the following routine uses:

- The information on this form will be treated confidentially to the extent allowed under the
  Freedom of Information Act (5 U.S.C. 552) and the Privacy Act (5 U.S.C 552a). Records from
  this system of records may be disclosed to the Department of Justice to determine whether
  disclosure of these records is required by the Freedom of Information Act.
- A record from this system of records may be disclosed, as a routine use, in the course of presenting evidence to a court, magistrate, or administrative tribunal, including disclosures to opposing counsel in the course of settlement negotiations.
- A record in this system of records may be disclosed, as a routine use, to a Member of Congress submitting a request involving an individual, to whom the record pertains, when the individual has requested assistance from the Member with respect to the subject matter of the record.
- 4. A record in this system of records may be disclosed, as a routine use, to a contractor of the Agency having need for the information in order to perform a contract. Recipients of information shall be required to comply with the requirements of the Privacy Act of 1974, as amended, pursuant to 5 U.S.C. 552a(m).
- 5. A record related to an International Application filed under the Patent Cooperation Treaty in this system of records may be disclosed, as a routine use, to the International Bureau of the World Intellectual Property Organization, pursuant to the Patent Cooperation Treaty.
- A record in this system of records may be disclosed, as a routine use, to another federal agency for purposes of National Security review (35 U.S.C. 181) and for review pursuant to the Atomic Energy Act (42 U.S.C. 218(c)).
- 7. A record from this system of records may be disclosed, as a routine use, to the Administrator, General Services, or his/her designee, during an inspection of records conducted by GSA as part of that agency's responsibility to recommend improvements in records management practices and programs, under authority of 44 U.S.C. 2904 and 2906. Such disclosure shall be made in accordance with the GSA regulations governing inspection of records for this purpose, and any other relevant (i.e., GSA or Commerce) directive. Such disclosure shall not be used to make determinations about individuals:
- 8. A record from this system of records may be disclosed, as a routine use, to the public after either publication of the application pursuant to 35 U.S.C. 122(b) or issuance of a patent pursuant to 35 U.S.C. 151. Further, a record may be disclosed, subject to the limitations of 37 CFR 1.14, as a routine use, to the public if the record was filed in an application which became abandoned or in which the proceedings were terminated and which application is referenced by either a published application, an application open to public inspection or an issued patent.
- A record from this system of records may be disclosed, as a routine use, to a Federal, State, or local law enforcement agency, if the USPTO becomes aware of a violation or potential violation of law or regulation.

PATENT REEL: 050634 FRAME: 0707

**RECORDED: 10/07/2019**